



11/C
7/8/03
Hayes

PATENT APPLICATION

Our Docket: UW Van den Engh

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Commissioner for Patents and Trademarks
Washington, D.C. 20231

On June 16, 2003, by Delbert J. Barnard.

Signature:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2878
Examiner: S. Lee
Applicant: Ger van den Engh
Serial No.: 09/847,466
Filed: May 1, 2001
Entitled: APPARATUS FOR DETERMINING RADIATION BEAM ALIGNMENT
Date: June 16, 2003

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
JUN 23 2003
TECHNOLOGY CENTER 2800

Responsive to the Office Action mailed January 15, 2003, entry of the following Amendments and consideration of the Remarks below is respectfully requested.